

Notice of References Cited	Application/Control No. 10/660,697	Applicant(s)/Patent Under Reexamination CHAMNESS, KEVIN ANDREW	
	Examiner Jeffrey R. West	Art Unit 2857	Page 1 of 1

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*	C	US-6,622,059	09-2003	Toprac et al.	700/121
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NON-PATENT DOCUMENTS

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*	U	Li et al., "Recursive PCA for adaptive process monitoring", Department of Chemical Engineering, The University of Texas at Austin, Austin, TX. Available online 21 August 2000
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.